Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/901,323	KRUPKA, EYAL	PKA, EYAL
Examiner	Art Unit	nit
Kevin Y. Kim	2611	

	SEARCHED		
Class	Subclass	Date	Examiner
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INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Inventor Search	49/06	1lm	
EAST" Text Search	4/9/06	New	